

Notice of References Cited	Application/Control No. 10/585,323		Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner SHEELA C. CHAWAN		Art Unit 2624	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0221856 A1	10-2005	Hirano et al.	455/557
*	B	US-6,198,846 B1	03-2001	Nishiwaki, Daisuke	382/178
*	C	US-5,978,520	11-1999	Maruyama et al.	382/294
*	D	US-6,335,986 B1	01-2002	Naoi et al.	382/190
*	E	US-6,687,401 B2	02-2004	Naoi et al.	382/190
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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